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APPLICANTS

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** CONTINUING DATA ***** KCC
 This application is a DIV of 09/826,098 04/05/2001 PAT 6,762,129

** FOREIGN APPLICATIONS ***** KCC
 JAPAN 2000-117502 04/19/2000

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature: KCC Initials:	STATE OR COUNTRY JAPAN	SHEETS DRAWING 16	TOTAL CLAIMS 13	INDEPENDENT CLAIMS 4
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 22204
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TITLE
 Dry etching method, fabrication method for semiconductor device, and dry etching apparatus

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
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